

FORM PTO-1449		US Dept. of Commerce Patent and Trademark Office		ATTORNEY DOCKET NO.		SERIAL NO.	
				ATMI-685		10/712,351	
		INFORMATION DISCLOSURE STATEMENT <small>(use several sheets if necessary)</small>		APPLICANT			
				Xueping Xu, et al.			
				FILING DATE		GROUP	
				November 13, 2003		1775	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER PARENTAL		PATENT NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
SJS	AA	5,637,531	6/10/1997	Porowski, et al.			
SJS	AB	5,679,152	10/21/1997	Tischler, et al.			
SJS	AC	6,559,075	5/6/2003	Kelly, et al.			
SJS	AD	6,413,627	7/2/2002	Motoki, et al.			
SJS	AE	6,468,347	10/22/2002	Motoki, et al.			
SJS	AF	2003/0080345	5/1/2003	Motoki, et al.			
SJS	AG	2003/0145783	8/7/2003	Motoki, et al.			
SJS	AH	6,440,823	8/27/2002	Vaudo, et al.			
SJS	AI	6,488,767	12/3/2002	Xu, et al.			
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY	CLASS	SUBCLAS S	TRANSLATION YES      NO
							X (abstract only)
<b>OTHER DOCUMENTS (Including Author, Title, Journal-Date, Page Number, Etc.)</b>							
SJS	AJ	S. Porowski, et al., J.Cryst. Growth, Vol. 78, 174, (1997)					
SJS	AK	M. Bockowski, J. Cryst. Growth, Vol. 246, 194 (2002)					
SJS	AL	M.K. Kelly, et al., Jpn. J. Appl. Phys., Vol. 38, pp. L217-L219, (1999)					
SJS	AM	Xu, et al., J. Electronic Materials, Vol. 31, 402, (2002)					
SJS	AN	J. Crystal Growth, Vol. 246, 223 (2002) and Physica Status Solidi (c), (2003)					
Continue on Page							
EXAMINER <i>Styli Slin</i>					DATE CONSIDERED 9/17/2005		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.							